IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| n re Patent Application of: |) | Confirmation No.: 1187 |
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| Koichiro TANAKA et al. |) | Examiner: Sang Yeop Pai |
| Serial No. 10/579,238 |) | Group Art Unit: 3742 |
| Filed: May 12, 2006 |) | |
| For: LASER IRRADIATION APPARATUS |) | |
| AND LASER IRRADIATION METHOD |) | |
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INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. § 1.56 and 37 C.F.R. §§ 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing information known to Applicant and requests that this information be made of record in the above identified application. Copies are submitted herewith in accordance with 37 C.F.R. § 1.98(a).

U.S. Patent No. 7,902,002 in the family of WO 2006/027912.

This Information Disclosure Statement is being submitted with a RCE. Therefore, no fee is required.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§ 1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 50-2280.

Respectfully submitted,

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